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Our Docket No: 42P13380

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Re Application of:

Nikonov, Dmitri E. et al.

Application No: 10/041,038

Filed: Dec. 28, 2001

For: Method and Apparatus for Wafer
Level Testing of Integrated Optical
Waveguide Circuits

Examiner: Kim, Ellen E.

Art Unit: 2874

PETITION TO AMEND UNDER 37 CFR 1.312

AMENDMENT UNDER 37 C.F.R. § 1.312
(Amendment After Allowance)

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Sir:
In Response to the Notice of Allowance mailed on 08/13/2004, the Applicants respectfully request that the Commissioner enter the following amendments.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that I am causing the above-referenced correspondence to be deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and that this paper or fee has been addressed to the Mail Stop Issue Fee, Commissioner for Patents, Alexandria, VA 22313.

November 15, 2004
Date of Deposit

Krista Mathieson.

Name of Person Mailing Correspondence

Krista Mathieson
Signature

Nov. 15, 2004
Date